

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sun-Ha HWANG, et al.

Serial No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: March 8, 2004

Examiner: Not yet assigned

For: SEMICONDUCTOR DEVICES AND METHODS OF FABRICATING THE SAME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits herewith PTO Form 1449 listing patents and publications of which he is aware which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR Section 1.56.

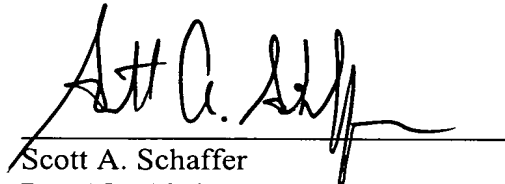
The above-referenced application is a division of U.S. Serial No. 10/289,721, filed November 6, 2002. It includes the same disclosure as U.S. patent application Serial No. 10/289,721.

It is understood that the listed references will be considered in the examination of the application and that no separate copies of the same prior art are required to be provided since they were previously cited or transmitted in the foregoing prior application. 37 CFR Section 1.98(d). Form(s) PTO 1449 is enclosed listing references cited by the Examining Attorney and submitted by applicant in the prior applications.

**Customer No. 20575**

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.



\_\_\_\_\_  
Scott A. Schaffer  
Reg. No. 38,610

MARGER JOHNSON & McCOLLOM, P.C.  
1030 SW Morrison Street  
Portland, OR 97205  
503-222-3613

**PATENT APPLICATION**

Atty. Docket No.: 4591-393 Serial No. Not yet assigned  
Applicant: Sun-Ha HWANG, et al.  
Filing Date: March 8, 2004 Group: Not yet assigned

**INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)**

**U.S. PATENT DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub Class</u>
_____	_____	5,741,735	04-1998	Violette et al.	438	279
_____	_____	6,627,502	09-2003	Cho, Shiu-Ying	438	265

**FOREIGN PATENT DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country</u>	<u>Name</u>
_____	_____	2001-77099	8/17/2001	Korea	Kim
_____	_____	2001-65747	7/11/2001	Korea	Baek, et al.

**OTHER DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language of Abstract for Korean Patent Publication No. 2001-77099 published 8/17/2001.
_____	_____	English language of Abstract for Korean Patent Publication No. 2001-65747 published 7/11/2001.

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_